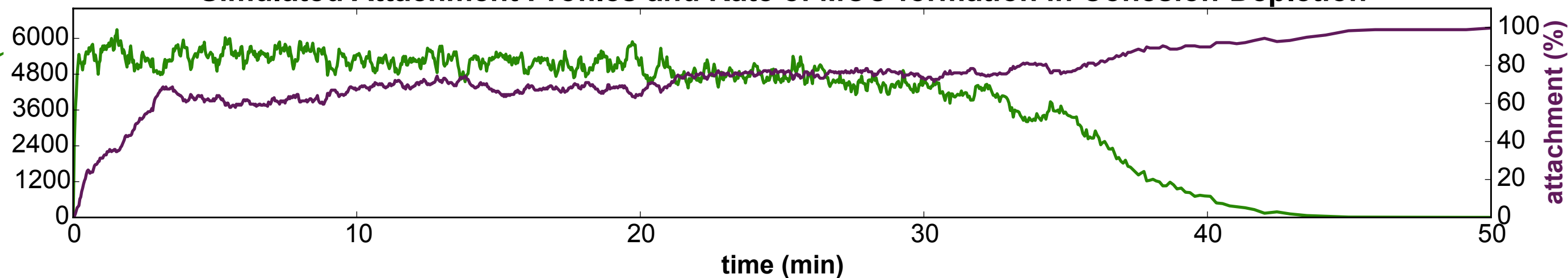


TEV + DMSO

Simulated Attachment Profiles and Rate of MCC-formation in Cohesion-Depletion

MCC formation (min⁻¹)



TEV + RO

MCC formation (min⁻¹)

